



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re application of

: **Confirmation No. 4334**

Junichiro YOSHIOKA et al.

: Docket No. 2001\_1740

Serial No. 09/990,387

: Group Art Unit 1753

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: Examiner Arun S. Phasge

SEMICONDUCTOR WAFER HOLDER AND  
ELECTROPLATING SYSTEM FOR PLATING  
A SEMICONDUCTOR WAFER

**Mail Stop: Amendment**

**PATENT OFFICE FEE TRANSMITTAL FORM**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Attached hereto is a check in the amount of \$630.00 to cover Patent Office fees relating to filing the following attached papers:

Petition for Extension of Time ..... \$450.00

Information Disclosure Statement: ..... \$180.00

A duplicate copy of this paper is being submitted for use in the Accounting Division, Office of Finance.

*The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.*

Respectfully submitted,

Junichiro YOSHIOKA et al.

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
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By

Michael S. Huppert  
Registration No. 40,268  
Attorney for Applicants

MSH/kjf  
WENDEROTH, LIND & PONACK, L.L.P.  
2033 K St., N.W., Suite 800  
Washington, D.C. 20006-1021  
Telephone (202) 721-8200  
August 24, 2005

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